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10/537,417	06/02/2005	Kimiyasu Satoh	267653US6PCT	6457	
OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, P.C. 1940 DUKE STREET			EXAMINER		
			CHOWDHURY, AFROZA Y		
ALEXANDRIA, VA 22314			ART UNIT	PAPER NUMBER	
			2629		
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			03/26/2008	ELECTRONIC	

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

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		Applicat	ion No.	Applicant(s)		
		10/537,4	17	SATOH ET AL.		
Office Action Summary		Examine	r	Art Unit		
		AFROZA	Y. CHOWDHURY	2629		
Period fo	The MAILING DATE of this commur or Reply	ication appears on th	e cover sheet with the	correspondence ac	ddress	
A SHO WHIC - Exter after - If NO - Failur Any r	ORTENED STATUTORY PERIOD F CHEVER IS LONGER, FROM THE M Issions of time may be available under the provisions SIX (6) MONTHS from the mailing date of this come period for reply is specified above, the maximum si ree to reply within the set or extended period for reply eply received by the Office later than three months and patent term adjustment. See 37 CFR 1.704(b).	MAILING DATE OF T s of 37 CFR 1.136(a). In no e munication. tatutory period will apply and by will, by statute, cause the ap	HIS COMMUNICATIO vent, however, may a reply be till expire SIX (6) MONTHS from plication to become ABANDONE	N. mely filed n the mailing date of this o ED (35 U.S.C. § 133).	,	
Status						
2a)⊠	Responsive to communication(s) file This action is FINAL . Since this application is in condition closed in accordance with the pract	2b)⊡ This action is for allowance excep	non-final. t for formal matters, pr		e merits is	
Dispositi	on of Claims					
5)□ 6)⊠ 7)□ 8)□ Applicati	Claim(s) 1-12 is/are pending in the at 4a) Of the above claim(s) is/at Claim(s) is/are allowed. Claim(s) 1-12 is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restrict on Papers The specification is objected to by the	tre withdrawn from o				
10)	The specification is objected to by the drawing(s) filed on is/are Applicant may not request that any objected to at the content of th	: a) ☐ accepted or bection to the drawing(s) g the correction is requ	be held in abeyance. Se red if the drawing(s) is ob	e 37 CFR 1.85(a). pjected to. See 37 C	, ,	
Priority u	ınder 35 U.S.C. § 119					
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 						
2) Notic 3) Inforr	t(s) e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (I nation Disclosure Statement(s) (PTO/SB/08) r No(s)/Mail Date	PTO-948)	4) Interview Summary Paper No(s)/Mail D 5) Notice of Informal I 6) Other:	ate		

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DETAILED ACTION

Response to Amendment

Applicant's amendment received on January 20, 2008 has been entered. Claims
 1-12 are currently pending. Applicant's arguments are addressed herein below.

2. JP references in IDS are not considered since English translation is not provided.

Claim Rejections - 35 USC § 103

- 5. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 6. Claims 1-7 and 9-12 are rejected under 35 U.S.C. 103(a) as being unpatentable over **Shigeki et al.** (JP Pub. 2002-259095) in view of **Yoshitaka et al.** (JP Pub. 11-212725) and in further view of **Divigalpitiya et al.** (US Pub. 2003/0205450).

As to claim 1, Shigeki et al. discloses an input apparatus that outputs coordinate values of an operation surface that the user has pressed as an input operation ([0040]), deforms the operation surface (fig. 6), and causes the user to feel a force sense as a feedback with the deformed operation surface ([0040]), comprising:

a deformation mechanism portion that deforms the operation surface (fig. 6);

a press force detection portion that detects whether the operation surface has been pressed ([0040]); and

a control portion ([0046]) that controls said deformation mechanism portion to start driving the actuator to gradually deform the operation surface in one direction and then in the reverse direction ([0040]).

Shigeki et al. does not explicitly teach the control portion that controls a piezoelectric actuator and period for deformation in one direction is larger than in the reverse direction.

Yoshitaka et al. teaches a control portion ([0020]) that controls deformation mechanism portion to start driving the piezoelectric actuator to gradually deform the operation surface in one direction and then in the reverse direction ([0050] – [0051], [0001] – [0002]), and

a piezoelectric device that detects an operation input position (abstract, [0126] – [0128]).

Yoshitaka et al. does not teach whether the piezoelectric element is a bi-morph device.

However, it is well known in the art that most piezoelectric actuators are composed of piezoelectric bi-morph device.

Therefore, it is obvious to one skill in the art at the time of the invention was made to include the piezoelectric element of Yoshitaka et al. into the input device of Shigeki et al. to make a piezoelectric actuator in order to let user feel a force sense as a feedback and detect an operation input position.

Shigeki et al. (as modified by Yoshitaka et al.) does not teach a period for which the operation surface is deformed in one direction is sufficiently larger than a period for which the operation surface is deformed in the reverse direction when said press force detection portion detects that the operation surface has been pressed.

Divigalpitiya et al. discloses the period for activate the operation (surface is deformed) in one direction is sufficiently larger than the period for which the operation surface is deformed in the reverse direction (restore the original position)(page 3, [0033]).

Therefore, it is obvious to one skill in the art at the time of the invention was made to combine the pressure activation device of Divigalpitiya et al. with the input device of Shigeki et al. (as modified by Yoshitaka et al.) to make a piezoelectric actuator in order to allow user to feel a click sense as a feedback with maximum deformation amount of the touch panel and low power consumption.

As to claim 2, Shigeki et al. (as modified by Yoshitaka et al. and Divigalpitiya et al.) teaches an input apparatus with the period for deformation in one direction is larger than in the reverse direction)(page 3, [0033], in Divigalpitiya et al.)..

Shigeki et al. (as modified by Yoshitaka et al. and Divigalpitiya et al.) does not teach the maximum deformation amount of the operation surface.

However, it is obvious for an input apparatus when the maximum deformation amount of the operation surface deformed by said deformation mechanism portion is

200 micro-meter or less, the period for which the operation surface is deformed in one direction is 33 times or more than the period for which the operation surface is deformed in the reverse direction.

As to claim 3, it is obvious for an input apparatus wherein the period for which the operation surface is deformed in the first direction is 200 msec or less.

As to claim 4, it is obvious that an input apparatus comprising:

a deformation amount set portion that sets the deformation amount of the panel surface corresponding to setting of the user,

wherein said control portion deforms the operation surface corresponding to setting of the deformation amount of the operation surface.

As to claim 5, Yoshitaka et al. discloses an input apparatus wherein said control portion gradually increases or decreases a drive voltage of the piezoelectric actuator always corresponding to the same waveform and varies the period for which the drive voltage increases or decreases corresponding to the waveform to vary the deformation amount of the operation surface in one direction ([0024] – [0025]).

As to claim 6, it is obvious that an input apparatus wherein said control portion controls said deformation mechanism portion to keep the operation surface deformed in the reverse direction until said press force detection portion detects that the operation

surface has been pressed.

As to claim 7, it is obvious for an input apparatus wherein said control portion controls said deformation mechanism portion to deform the operation surface in the reverse direction for a predetermined period and the operation surface for a period sufficiently longer than the predetermined period so that the voltage applied to the piezoelectric actuator becomes 0 V when said press force detection portion detects that the operation surface has been pressed.

As to claim 9, Yoshitaka et al. discloses an input apparatus comprising: a display portion that transmits the operation surface and displays a screen, wherein when an operation function item displayed on said display portion is pressed through the operation surface, the operation function item is selected and input ([0010]).

As to claim 10, Yoshitaka et al. teaches an input apparatus relates to a portable electronic apparatus ([0001]).

As to claim 11, Yoshitaka et al. teaches an input apparatus relates to a remote control apparatus ([0001]).

Claim 12 is rejected the same as claim 1 above.

7. Claim 8 is rejected under 35 U.S.C. 103(a) as being unpatentable over **Shigeki et al.** (JP Pub. 2002-259095) in view of **Yoshitaka et al.** (JP Pub. 11-212725) and in further view of **Divigalpitiya et al.** (US Pub. 2003/0205450) and **Wu et al.** (US. Patent 6,422,757).

As to claim 8, Shigeki et al. (as modified by Yoshitaka et al. and Divigalpitiya et al.) teaches an input apparatus with spacer (see [0009] – [0010] in Shigeki et al.).

Shigeki et al. (as modified by Yoshitaka et al. and Divigalpitiya et al.) does not explicitly introduce a piezoelectric actuator with first, second, and third spacers.

Wu et al. discloses a piezoelectric actuator with three spacers (col. 3, line56 – col. 4, line 14).

Therefore, it is obvious to one skill in the art at the time of the invention was made to use the idea of Wu et al. of using more than one spacer to make a piezoelectric actuator with the input device of Shigeki et al. (as modified by Yoshitaka et al. and Divigalpitiya et al.) to make a piezoelectric actuator with the desired arrangement of spacers in order to create gap.

Also, it is a design choice to make a piezoelectric actuator that is curved in the direction perpendicular to the surfaces on which three spacers are disposed so as to vary the distance between the front surface of the first spacer and the front surface of the second and third spacers and deform the operation surface.

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Response to Arguments

8. Applicant's arguments filed **January 20, 2008** have been fully considered but they are not persuasive.

Applicant argues that Shigeki et al. does not teach a control portion that controls the deformation mechanism portion to start driving the piezoelectric actuator to gradually deform the operation surface in one direction and then in the reverse direction.

The Examiner respectfully disagrees. Shigeki et al. (as modified by Yoshitaka et al.) discloses a control portion ([0020]) that controls deformation mechanism portion to start driving the piezoelectric actuator to gradually deform the operation surface in one direction and then in the reverse direction ([0050] – [0051], [0001] – [0002], in Yoshitaka et al.).

9. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of

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the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to AFROZA Y. CHOWDHURY whose telephone number is (571)270-1543. The examiner can normally be reached on 7:30-5:00 EST, 5/4/9.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Bipin Shalwala can be reached on 571-272-7681. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

AC 3/15/2008

> /Bipin Shalwala/ Supervisory Patent Examiner, Art Unit 2629